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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Application of :
Kouji IWASAKI :
Serial No. 10/712,147 : Group Art Unit - 1742
Filed: November 13, 2003 : Examiner - Scott R. Kastler
For: METHOD AND SYSTEM FOR :
FABRICATING THREE- :
DIMENSIONAL MICRO- :
STRUCTURE : Docket No. S005-5148

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Mail Stop AMENDMENT
COMMISSIONER FOR PATENTS
P.O. BOX 1450
ALEXANDRIA, VA 22313-1450

RESPONSE

S I R:

In response to the Office Action dated June 13,
2006, applicant amends his application as follows:

ELECTION OF INVENTION:

Applicant provisionally elects, with traverse, the
invention characterized by the Examiner as Group I drawn to a
method of fabricating a three dimensional microstructure and
submit that claims 1-6 and 9-15 are readable on the elected
invention.

MAILING CERTIFICATE ON PAGE 3